



U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

**REQUEST FOR EXTENSION  
OF TIME PURSUANT TO  
37 C.F.R. § 1.136(a)**

Docket Number:  
**10191/1614**

Conf. No.:  
**3872**

Application Number  
**09/720,720**

Filing Date  
**February 28, 2001**

Reissue Examiner  
**Binh TRAN**

Art Unit  
**3872**

Invention Title  
**METHOD FOR ELIMINATING DEFECTS  
IN SILICON ELEMENTS THROUGH  
SELECTIVE ETCHING**

Inventor:  
**Richard SPITZ et al.**

Commissioner for Patents  
Washington D.C. 20231

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first class mail in an envelope addressed  
to: Commissioner for Patents, Washington, DC 20231.

Dated: January 28, 2003

Reg. No. 36,197

Signature: \_\_\_\_\_

Jong H. Lee

Applicants respectfully request a one-month extension of time in which to respond to the office action dated October 1, 2002 for which a response period expiring on January 1, 2003 was set. The extended period expires on February 1, 2003.

1. The Commissioner is hereby authorized to charge payment of the 37 C.F.R. § 1.136(a) extension fee of **\$110.00** to the Deposit Account of **Kenyon & Kenyon**, Deposit Account number **11-0600**. The office is also authorized to charge any additional fees, or credit overpayments, associated with this paper to Deposit Account **11-0600**.
2. A duplicate copy of this form is enclosed.

Dated: January 28, 2003

By: \_\_\_\_\_

Jong H. Lee (Reg. No. 36,197)

**KENYON & KENYON**  
One Broadway  
New York, N.Y. 10004  
(212) 425-7200 (telephone)

CUSTOMER NO. 26646